

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION <small>(Use several sheets if necessary)</small>				Docket Number (Optional) 14274		Application Number 09/774,921	
				Applicant(s) Hideaki Shiraishi			
				Filing Date January 31, 2001		Group Art Unit 2871	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS							
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
DN	03-258476	11/18/1991	Japan	—	—	YES	NO
DN	11-160667	6/18/1999	Japan	—	—	} Abstract	
DN	11-014953	1/22/1999	Japan	—	—	} only	
—	53-041945	4/11/1978	Japan	—	—		
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
*	Microfilm of Japanese Utility Model Application No. Shows S1-123239 (Japanese Unexamined Utility Model Application No. 53-041945 dated April 11, 1978)						
EXAMINER	DNGUYEN			DATE CONSIDERED		03/31/04	
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